



Attorney Docket No. 1186.1015

CoFC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kenzo FUKUYOSHI et al.

Application No.: 09/768,454

ATTENTION

Confirmation No.: 3942

CERTIFICATE OF CORRECTION

Filed: January 25, 2001

BRANCH

U.S. Patent No.: 6,950,140

Batch No.:

Issued: September 27, 2005

For: A MICRO LENS ARRAY INCLUDING AN ETCHED DITCH AND TRANSPARENT
RESIN LAYER AND METHOD OF MANUFACTURING SAME (As Amended)

REQUEST FOR CERTIFICATE OF CORRECTION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Certificate
JUN 08 2006
of Correction

Sir:

Patentee(s) respectfully request(s) that a Certificate of Correction be issued in the
subject patent, pursuant to 35 U.S.C. §254 and 37 C.F.R. §1.322, to correct the mistake(s)
shown on the attached Form PTO-1050.

Since the mistakes are Patent Office mistakes, it is believed that no fee is required.

Respectfully submitted,

STAAS & HALSEY LLP

Date: June 2, 2006

By: David M. Pitcher
David M. Pitcher
Registration No. 25,908

1201 New York Ave, N.W., 7th Floor
Washington, D.C. 20005
Telephone: (202) 434-1500
Facsimile: (202) 434-1501

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(Also Form PTO-1050)

UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

PATENT NO : 6,950,140

DATED : September 27, 2005

INVENTOR(S) : Kenzo FUKUYOSHI et al.

First Page, Column 1 (Title), delete "SOLID IMAGE-BACKUP DEVICE HAVING A MICRO LENS ARRAY AND METHOD OF MANUFACTURING THE SAME" and insert - - "A MICRO LENS ARRAY INCLUDING AN ETCHED DITCH AND TRANSPARENT RESIN LAYER AND METHOD OF MANUFACTURING SAME" - -, therefor.

MAILING ADDRESS OF SENDER:

STAAS & HALSEY LLP
1201 New York Ave., N.W.
7th Floor
Washington, DC 20005

PATENT NO. 6,950,140

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